

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
)
Fuyuhiko INOUE)
)
Application No.: 09/934,081) Group Art Unit: 2877
)
Filed: August 22, 2001) Examiner: Not yet assigned
)
For: INTERFEROMETER SYSTEM)
)

Assistant Commissioner for Patents
Washington, DC 20231

Sir:

SUBMISSION OF FORMAL DRAWINGS


Subject to the approval of the Examiner, please replace the informal drawings with the five (5) sheets of formal drawings filed herewith (Figures 1 - 8). If the formal drawings for any reason are not in full compliance with the pertinent statutes and regulations, please so advise the undersigned.

If any fees are necessary for the submission of these formal drawings, please charge our Deposit Account No. 06-0916.

Respectfully submitted,

FINNEGAN, HENDERSON, FARABOW,
GARRETT & DUNNER, L.L.P.

Dated: December 20, 2001

By: 
Jemy Soegeng
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